

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No.: 5877

Art Unit: 1763

Examiner: Allan W. Olsen

For: MASK BLANK FOR CHARGED PARTICLE BEAM EXPOSURE, METHOD OF FORMING MASK BLANK AND MASK FOR CHARGED PARTICLE BEAM EXPOSURE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the notice of non-compliant amendment, for which a petition to revive is submitted herewith, and in response to office action to the office action dated July 16, 2007, please make the following amendments:

Claim amendments begin on page 2 of this document.

Remarks begin on page 4 of this document.